



1174 Qndt 4  
Duncen  
512103

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/099,840  
Filing Date ..... March 12, 2002  
Inventor ..... James J. Hofmann  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2818  
Examiner ..... Hoang, Quoc Dinh  
Attorney's Docket No. ..... MI22-1803  
Title: "Methods of Forming Patterns for Semiconductor Constructions; and Molds  
Configured to Patterned Masses Associated with Semiconductor Constructions"

RESPONSE TO APRIL 24, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

RECEIVED

MAY 20 2003

TECHNICAL CENTER 2800

AMENDMENTS

None.

EV085430202